

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Elazar R. Edelman, Aruna Nathan and Matthew A. Nugent

Batch No.: U 45

Serial No: 08/458,978

Art Unit: 1808

Filed: June 2, 1995

Examiner: D. Naff

For: *INHIBITION OF VASCULAR SMOOTH MUSCLE CELL PROLIFERATION
WITH IMPLANTED MATRIX CONTAINING VASCULAR ENDOTHELIAL
CELLS (as amended)*

Box ISSUE FEE
Assistant Commissioner
for Patents
Washington, D.C. 20231

RECEIVED
Publishing Division
JAN 12 1998

09

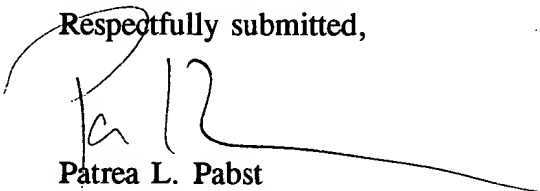
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TRANSMITTAL OF ISSUE FEE

Sir:

Transmitted herewith are the Issue Fee Transmittal Form PTOL-85B (in duplicate), a check in the amount of \$1320.00 covering the issue fee, and a check in the amount of \$60.00 covering the cost of twenty copies of the patent.

Respectfully submitted,


Patrea L. Pabst
Reg. No. 31,284

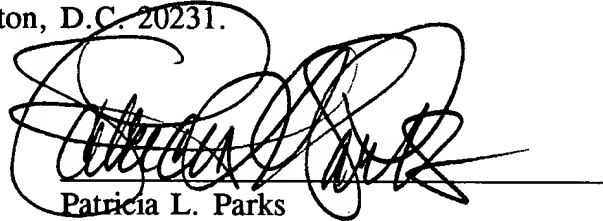
Date: January 9, 1998

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U.S.S.N.: 08/458,978
Filed: June 2, 1995
TRANSMITTAL OF ISSUE FEE

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.10

I hereby certify that this Transmittal of Issue Fee and any documents referred to as attached therein are being deposited with the United States Postal Service on this date, January 9, 1998, in an envelope as "Express Mail Post Office to Addressee" service under 37 C.F.R. § 1.10, Mailing Label Number EM 181 247 645 US addressed to Box Issue Fee, Assistant Commissioner for Patents, Washington, D.C. 20231.



Patricia L. Parks

Date: January 9, 1998



OFFICE OF THE SECRETARY OF THE CORPORATION

I, Kathryn A. Willmore, do hereby certify that I am Secretary of the Executive Committee of the Corporation of the Massachusetts Institute of Technology and that the following is a true and correct copy of a vote duly adopted by said Executive Committee at a regular meeting duly held on May 26, 1994, at which a quorum was present and voting throughout:

VOTED: To rescind, effective May 26, 1994, a vote of February 5, 1993 granting single signing authority to John T. Preston, Director of Technology Development, and Lita Nelsen, Director of the MIT Technology Licensing Office, for patent and licensing documents specifically described in seven (7) subsections contained in the vote.

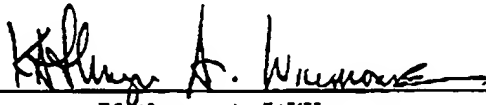
VOTED: That J. David Litster, Vice President and Dean for Research, John T. Preston, Director of Technology Development, and Lita Nelsen, Director of the MIT Technology Licensing Office, acting alone, are hereby authorized, effective May 26, 1994, to sign in the name and on behalf of the Institute the following described documents as they relate to intellectual property, and licensing at MIT:

- (1) U.S. patent, trademark, and copyright filing, prosecution, and maintenance documents, including U.S. Government licenses
- (2) Corresponding foreign documents including power of attorney authorization forms for the purpose of filing only
- (3) Faculty royalty-sharing and interinstitutional royalty-sharing agreements
- (4) Small entity status verification forms for the purpose of reducing filing costs
- (5) Materials transfer agreements
- (6) Non-disclosure forms required to disclose MIT patent applications to industry

VOTED: That Jarmila Z. Hrbek, Patent Administrator and Office Manager, acting alone, is hereby authorized, effective May 26, 1994, to sign in the name and on behalf of the Institute the following described documents as they relate to intellectual property at MIT:

- (1) U.S. Patent prosecution and maintenance documents, including U.S. Government licenses
- (2) Foreign prosecution and maintenance documents, including power of attorney authorization forms for the purpose of filing only
- (3) Small entity status verification forms for the purpose of reducing filing costs.

IN WITNESS WHEREOF, I have hereunto set my hand and seal of the Massachusetts Institute of Technology on this 14th day of June, 1994.



Kathryn A. Willmore
Secretary of the Executive Committee
of the Corporation of
Massachusetts Institute of Technology